

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Response Under 37 CFR 1.116 - Expedited Procedure

Customer Number: 20277

Masahiro NAKAYAMA, et al.

Confirmation Number: 1716

Application No.: 10/662,524

Group Art Unit: 3723

Filed: September 16, 2003

Examiner: Dung V. Nguyen

For: CHAMFERED FREESTANDING NITRIDE SEMICONDUCTOR WAFER AND METHOD OF CHAMFERING NITRIDE SEMICONDUCTOR WAFER

Mail Stop AF  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

☒  
☐  
☐

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	2	20	0	\$50.00 =	\$0.00
Independent Claims	1	3	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

☐Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.☒

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL &amp; EMERY LLP

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Please recognize our Customer No. 20277 as our  
 correspondence address.



Packet No.: 052775-0024

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Masahiro NAKAYAMA, et al.

RESPONSE UNDER 37 C.F.R. 1.116  
EXPEDITED PROCEDURE

Application No.: 10/662,524

Customer No.: 20277

Filed: September 16, 2003

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Group Art Unit: 3723

Examiner: Dung V. Nguyen

Title: CHAMFERED FREESTANDING NITRIDE SEMICONDUCTOR WAFER AND  
METHOD OF CHAMFERING NITRIDE SEMICONDUCTOR WAFER

**AMENDMENT UNDER 37 C.F.R. § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the final Office

Action dated August 8, 2006, pursuant to 37 C.F.R. § 1.116.

**Amendments to the Claims** begin on page 2.

**Remarks** begin on page 4.